

Form PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Atty Docket No. AMDSP0499US	Serial No. 09/824,933
	Applicant: Lin	
	Filing Date April 3, 2001	Group Not yet known



U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub-class	Filing Date if Appropriate
K.N.	3,936,858	02/03/76	Seeds et al.			
K.N.	4,498,227	02/12/85	Howell et al.			
K.N.	5,194,395	03/16/93	Wada			
K.N.	5,244,819	09/14/93	Yue			
K.N.	5,272,104	12/21/93	Schrantz et al.			
K.N.	5,443,661	08/22/95	Oguro et al.			
K.N.	5,453,153	09/26/95	Fan et al.			
K.N.	5,501,993	03/26/96	Borland			
K.N.	5,646,053	07/08/97	Schepis et al.			

OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
K.N.	Wolf et al.; "Silicon Processing for the VLSI Era"; Crystalline Defects, Thermal Processing and Gettering; Basic Gettering Principles; Volume 1: Process Technology; pgs. 63-70.
K.N.	Dziesiatv et al.; "Improved SI-EPI-Wafers by Buried Damage Layer for Extrinsic Gettering; pgs. 292-296.
K.N.	IBM Technical Disclosure Bulletin; "Gettering Technique and Structure; May 1975.
K.N.	Wong et al.; "Nanoscale CMOS"; Proceedings of the IEE, Vol. 87, No. 4; April 1999; pgs. 537-570.

EXAMINER <i>K. Hennigsen</i>	DATE CONSIDERED 12/17/02
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

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Serial No.

AMDSP0448US

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LIST OF PATENTS AND PUBLICATIONS
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INFORMATION DISCLOSURE STATEMENT

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Not yet known

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U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub-class	Filing Date if Appropriate
KN	5,753,560	05/19/98	Hong et al.			
KN	5,773,152	06/30/98	Okonogi			
KN	5,795,809	08/18/98	Gardner et al.			
KN	5,807,771	09/15/98	Vu et al.			
KN	5,818,085	10/06/98	Hsu et al.			
KN	5,882,990	03/16/99	DeBusk et al.			
KN	5,899,732	05/04/99	Gardner et al.			
KN	5,926,727	07/20/99	Stevens et al.			
KN	5,929,508	07/27/99	Delgado et al.			
KN	5,965,917	10/12/99	Maszara et al.			
KN	5,976,956	11/02/99	Gardner et al.			
KN	6,001,711	12/14/99	Hashimoto			
KN	6,010,950	01/04/00	Okumura et al.			
KN	6,013,584	01/11/00	M'Saad			
KN	6,022,793	02/08/00	Wijaranakula et al.			
KN	6,024,888	02/15/00	Watanabe et al.			
KN	6,083,324	07/04/00	Henley et al.			
KN	6,093,624	07/25/00	Letavic et al.			
KN	6,100,202	08/08/00	Lin et al.			
KN	6,114,223	09/05/00	Gonzalez et al.			
KN	6,133,123	10/17/00	Gonzalez			

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*Khuenmayer**12/17/02*

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